



520.41003X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KIMURA, et al.
Application No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE MANUFACTURING METHOD OF THE SAME,
SEMICONDUCTOR DEVICE AND ELECTRONIC DEVICE
Art Unit: 2813
Examiner: L. M. Schillinger

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 1, 2005

Sir:

In response to the Office Action dated October 1, 2004, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims and

Remarks are included following the amendments.